

## Accepted Manuscript

Growth of  $\text{YBa}_2\text{Cu}_3\text{O}_7$  superconductor thin films using ethanolamine-based solutions via simple spin coating

Katsuhiko Moriya, Kazuki Igarashi, Hazuki Watanabe, Hayato Hasegawa, Tetsuo Sasaki, Arata Yasuda

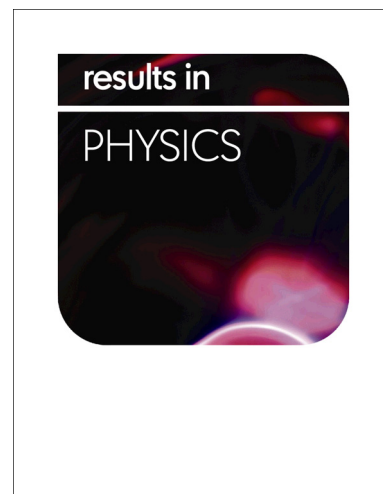
PII: S2211-3797(18)30968-9  
DOI: <https://doi.org/10.1016/j.rinp.2018.09.020>  
Reference: RINP 1665

To appear in: *Results in Physics*

Received Date: 20 April 2018  
Accepted Date: 9 September 2018

Please cite this article as: Moriya, K., Igarashi, K., Watanabe, H., Hasegawa, H., Sasaki, T., Yasuda, A., Growth of  $\text{YBa}_2\text{Cu}_3\text{O}_7$  superconductor thin films using ethanolamine-based solutions via simple spin coating, *Results in Physics* (2018), doi: <https://doi.org/10.1016/j.rinp.2018.09.020>

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***Growth of YBa<sub>2</sub>Cu<sub>3</sub>O<sub>7</sub> Superconductor Thin Films using  
Ethanolamine-based Solutions via Simple Spin Coating***

Katsuhiko Moriya<sup>a,b</sup>, Kazuki Igarashi<sup>b</sup>, Hazuki Watanabe<sup>b</sup>, Hayato Hasegawa<sup>c</sup>,  
Tetsuo Sasaki<sup>d</sup>, Arata Yasuda<sup>b,c</sup>

*a. Department of Electrical and Electronic Engineering, National Institute of Technology, Tsuruoka*

*College, Sawada104, Inooka, Tsuruoka, 997-8511, JAPAN*

*b. Department of Creative Engineering, National Institute of Technology, Tsuruoka College,*

*Sawada 104, Inooka, Tsuruoka, 997-8511, JAPAN*

*c. Department of Control and Information Systems Engineering, National Institute of Technology,*

*Tsuruoka College, Sawada 104, Inooka, Tsuruoka, 997-8511, JAPAN*

*d. Research Institute of Electronics, Shizuoka University, Johoku 3-5-1, Naka-ku, Hamamatsu*

*432-8011, JAPAN*

**Corresponding author: Arata Yasuda**

Phone number: +81-(0)235-25-9064

E-mail address: y-arata@tsuruoka-nct.ac.jp

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